



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jung-Sook GOO et al.

Title: STRAINED SILICON MOSFET
HAVING IMPROVED THERMAL
CONDUCTIVITY AND METHOD
FOR ITS FABRICATION

Application No.: 10/658,479

Filing Date: 9 September 2003

Examiner: H. TRINH

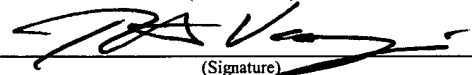
Art Unit: 2814

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REPLY TO OFFICIAL ACTION OF 25 AUGUST 2004
UNDER 37 CFR §1.111

Mail Stop AMENDMENT
Commissioner for Patents
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Sir:

Applicant hereby replies to the official action mailed 25 August 2004.

Reconsideration in view of the following amendments and remarks is requested.